## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re A	Application of:	)	
Tokuhisa OHIWA, et al.		) <i>Prior</i> Group Art Unit: 2823	
<i>Div. of</i> Application No.: 09/604,724, filed June 28, 2000		) <i>Prior</i> Examiner:	Maldonado, Julio J.
Filed:	Herewith	) )	
For:	METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE	) )	
P.O. E	nissioner for Patents Box 1450 ndria, VA 22313-1450		
Sir:			

## PRELIMINARY AMENDMENT

Please amend the above-identified divisional patent application as set forth in this paper.

Amendments to the Specification are shown on page 2 of this paper.

Amendments to the Claims begin on page 3 of this paper.

Remarks begin on page 8 of this paper.